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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99) | Application Number | | 10588981 |
| | Filing Date | | 2006-08-10 |
| | First Named Inventor | RODERICK BOSWELL | |
| | Art Unit | 2821 | |
| | Examiner Name | NOT YET ASSIGNED | |
| | Attorney Docket Number | F146 | |

U.S.PATENTS

| Examiner Initial* | Cite No | Patent Number | Kind Code ¹ | Issue Date | Name of Patentee or Applicant of cited Document | Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear |
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| | 1 | 2008094297 | WO | | 2008-08-07 | FEI COMPANY | | <input type="checkbox"/> |
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| 3 | JIANG ET AL., X., "Mini RF-Driven Ion Sources for Focused Ion Beam Systems," Review of Scientific Instruments, American Institute of Physics, April 2003, pgs. 2288-2292, Volume 74, No. 4. | <input type="checkbox"/> |
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| 6 | YIN ET AL., Y., "Miniaturization of Inductively Coupled Plasma Sources," Plasma Science, October 1999, pgs. 1516-1524, Volume 27, Issue 5. | <input type="checkbox"/> |

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